



IP
PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Re the application of:

Adrian Kiermasz

Application No. 10/743,923

Filed: December 22, 2003

For: LINEAR CHEMICAL MECHANICAL
PLANARIZATION (CMP) SYSTEM AND
METHOD FOR PLANARIZING A WAFER IN A
SINGLE CMP MODULE

) Group Art Unit: 2891
)
) Examiner: Zarneke, David A
)
) Atty. Docket No. LAM2P452
)
) Date: July 21, 2005

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope to: Commissioner for Patents, P. O. Box 1450, Alexandria, VA 22313-1450 on July 21, 2005.

Signed: *Michael K. Hsu*

Michael K. Hsu

Mail Stop: Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Transmitted herewith is Response to Restriction Requirement in the above-identified application.

The fee has been calculated as shown below.

	Claims Remaining After Amendment	Highest Previously Paid For	Present Extra	SMALL ENTITY RATE FEE	OR	LARGE ENTITY RATE FEE
TOTAL CLAIMS	<u>19</u> -	<u>19</u>	<u>00</u>	X 25 = \$	OR	X 50 = \$.00
INDEP CLAIMS	<u>04</u> -	<u>04</u>	<u>00</u>	X100 = \$	OR	X200 = \$.00
[] Multiple Dependent Claim Present and Fee Not Previously Paid				\$180		\$360
			TOTAL	\$ <u> </u>		\$ <u>.00</u>

- ☐ Applicant(s) hereby petition for a ____ month(s) extension of time to respond to the outstanding Office Action.
- ☒ Applicant(s) believe that no Extension of Time is required; however, if it is determined that such an extension is required, Applicant(s) hereby petition that such an extension be granted and authorize the Commissioner to charge the required fees for an Extension of Time under 37 CFR 1.136 to Deposit Account No. 50-0805.
- ☐ Enclosed is our Check No. _____ in the amount of \$ _____ to cover the additional claim fee and/or extension of time fees.
- ☒ If the required fees are missing or any additional fees are required to facilitate filing the enclosed response, please charge such fees or credit any overpayment to Deposit Account No. 50-0805 (Order No. LAM2P452). A copy of this sheet is enclosed.

Respectfully submitted,
MARTINE PENILLA & GENCARELLA, LLP

Michael K. Hsu

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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the application of:

Kiermasz

Application No.: 10/743,923

Confirmation No.: 9016

Filed: December 22, 2003

For: Linear Chemical Mechanical
Planarization (CMP) System and Method for
Planarizing a Wafer in a Single CMP Module

)
) Examiner: Zarneke, David A

)
) Group Art Unit: 2891

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) Atty. Docket No: LAM2P452

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Signed: _____

Michael K. Hsu

RESPONSE TO RESTRICTION REQUIREMENT

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the Restriction Requirement mailed June 21, 2005, Applicant hereby elects, without traverse, Group III, claims 13-18 to prosecute in the above-identified patent application.

Should the Examiner have any questions concerning this matter, the undersigned can be reached at the telephone number set out below.

Respectfully submitted,
MARTINE PENILLA & GENCARELLA, LLP

Michael K Hsu, Esq.

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